

FORM PTO-1449 Page 1 of 1	Atty. Docket No.: H0004490(1100.1226101)	Serial No.: 10/750,580
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Robert E. Higashi et al.	
	Filing Date: December 29, 2003	Group Art: unknown

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	
TON	5,895,233	04/1999	Higashi et al.	
I	6,036,872	03/2000	Wood et al.	
	6,359,333	03/2002	Wood et al.	
TON	6,627,892	09/2003	Cole	

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

TON	Motamedi et al., "Antireflection Surfaces in Silicon Using Binary Optics Technology," Applied Optics, Vol. 31, No. 2, pp. 4371-4376, August 1, 1992 2002
EXAMINER: <i>[Signature]</i>	DATE CONSIDERED: 12/02/2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.